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APPLICATION NUMBER	FILING OR 371(c) DATE	FIRST NAMED APPLICANT	ATTY. DOCKET NO./TITLE
10/566,170	01/27/2006	Yoshinobu Sekiguchi	00862.109138.

**CONFIRMATION NO. 2513**

5514  
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**Title:** Semiconductor film manufacturing method and substrate manufacturing method

**Publication No.** US-2006-0246688-A1

**Publication Date:** 11/02/2006

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